

USSN: 10/810,069Docket No.: 55752US018**Amendment to the Specification**

Please amend paragraph 0006 as shown below in marked form:

[0006] The disclosed invention includes a process and apparatus for coating a moving substrate of indefinite length in a controlled environment using low volumes of filtered air or specialty gases. The disclosed process and apparatus utilize a close-coupled enclosure that envelopes envelops the moving substrate from at least a coating applicator to a dryer or curing station, the close-coupled enclosure being supplied with one or more streams of conditioned gas flowing at a rate sufficient to reduce materially the close-coupled enclosure particle count. The invention thus provides in one aspect a process for coating a moving substrate of indefinite length comprising conveying the substrate past a coating applicator and to a dryer or curing station in a close-coupled enclosure or series of interconnected close-coupled enclosures while supplying the enclosure or series of enclosures with one or more streams of conditioned gas flowing at a rate sufficient to reduce materially the particle count(s) in a close-coupled enclosure.